

In re the Application of: Mamoru NAKASUJI et al. Group Art Unit: 2881

Serial No.: 09/891,511 Examiner: Jack I. Berman

Filed: June 27, 2001 Confirmation No.: 8779

For: INSPECTION SYSTEM BY CHARGED PARTICLE BEAM AND METHOD OF MANUFACTURING DEVICES USING THE SYSTEM

Attorney Docket Number: 010819

Customer Number: 38834

## AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Date: January 31, 2005

Sir:

In response to the Office Action dated September 30, 2004, the response date of which having been extended by one month to January 30, 2005, Applicants amend the claims as follows and submit the following remarks.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks/Arguments begin on page 24 of this paper.